



DOCKET NO: 215811US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
YASUJI HIRAMATSU, ET AL. : EXAMINER: WILLIAMS, A.
SERIAL NO: 09/926,464 :
FILED: JANUARY 10, 2002 : GROUP ART UNIT: 2826
FOR: CERAMIC SUBSTRATE FOR A :
SEMICONDUCTOR
PRODUCING/EXAMINING
DEVICE

AMENDMENT AND REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action of July 8, 2003, Applicants respectfully request reconsideration of the above-identified application in view of the following amendment and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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